



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Art Unit: **2815**

Application Number: **10/743,793**

Examiner: **Jay C. Kim**

Filed: **December 24, 2003**

Confirmation Number: **9788**

For: **Semiconductor substrate and manufacturing method thereof**

Attorney Docket Number: **032206**
Customer Number: **38834**

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 18, 2008

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 18, 2008 for 1 month from June 18, 2008 to July 18, 2008.

Attached please find a check in the amount of \$120.00 for the cost of the extension of time. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

Kenneth H. Salen
Attorney for Applicants
Registration No. 43,077
Telephone: (202) 822-1100
Facsimile: (202) 822-1111

KHS/mra

07/21/2008 SZEWDIE1 00000091 10743793

01 FC:1251

120.00 0P